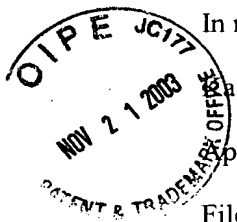


**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#23  
RCE  
12/12/03  
OJF



In re the Application of

Yazuhiko OKAWA et al.

Application No.: 09/866,800

Filed: May 30, 2001

For: SEMICONDUCTOR DEVICE HAVING  
ELECTROSTATIC PROTECTION CIRCUIT AND  
METHOD OF FABRICATING THE SAME

Group Art Unit: 2826

Examiner: J. Mondt

Docket No.: 109657

**MAIL STOP RCE**

**LARGE ENTITY REQUEST FOR  
CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. §1.114, Applicants hereby request continued examination.

Applicants further request entry and consideration of the attached submission.

The above-identified application was filed on or after June 8, 1995. Thus, entry is proper under 37 C.F.R. §1.114(d).

Attached hereto is our check no. 148382 in the amount of \$770.00 as payment of the fees set forth in 37 C.F.R. §1.17(e). The Commissioner is hereby authorized to charge any additional fees or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two duplicate copies of this page are enclosed.

Respectfully submitted,

*James A. Oliff*

James A. Oliff  
Registration No. 27,075

Jaquelin K. Spong  
Registration No. 52,241

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770.00 DP

JAO:JKS/scg

Date: November 21, 2003

OLIFF & BERRIDGE, PLC  
P.O. Box 19928  
Alexandria, Virginia 22320  
Telephone: (703) 836-6400

**DEPOSIT ACCOUNT USE  
AUTHORIZATION**

Please grant any extension  
necessary for entry;  
Charge any fee due to our  
Deposit Account No. 15-0461